

FILED UNIT

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|--|---|------------|-------|----------|----------|-----------------------|
| APPLICANTS | APPLICATION NO. | CONT/PRIOR | CLASS | SUBCLASS | ART UNIT | EXAMINER |
| | 09/856139 | D F | 257-- | 745 | 3814 | Chaudhri A. D. MAI |
| TITLE | Fumiaki Maruyama Naoki Naito Atsuo Uchiyama | | | | | |
| | BEST AVAILABLE COPY | | | | | |
| Wafer, epitaxial filter, and method of manufacture thereof | | | | | | |
| PTO-2040 12/89 | | | | | | |

WARNING

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(Rev. 1/80)

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